



DOCKET NO.: H0498.70173US00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Rahul Singhvi, et al.  
Serial No.: 10/032,280  
Confirmation No.: 6387  
Filed: December 21, 2001  
For: METHOD OF FORMATION OF MICROSTAMPED  
PATTERNS OF PLATES FOR ADHESION OF CELLS  
AND OTHER BIOLOGICAL MATERIALS, DEVICES  
AND USES THEREFOR

Examiner: Deborah K. Ware  
Art Unit: 1651

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**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to MAIL STOP RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the 1 day of September, 2005.

  
Signature

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**MAIL STOP RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**STATEMENT FILED PURSUANT TO THE DUTY OF**  
**DISCLOSURE UNDER 37 C.F.R. §§1.56, 1.97 AND 1.98**

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. §§1.56, 1.97 and 1.98, the Applicants request consideration of this Information Disclosure Statement.

**PART I: Compliance with 37 C.F.R. §1.97**

This Information Disclosure Statement has been filed before the mailing of a first Office Action after the filing of a request for continued examination under 37 C.F.R. §1.114. No fee or certification is required.

**PART II: Information Cited**

The Applicants hereby make of record in the above-identified application the information listed on the attached form PTO-1449 (modified). The order of presentation of the references should not be construed as an indication of the importance of the references.

The Applicant would like to bring to the Examiner's attention the following co-pending applications that may contain subject matter related to this application:

<u>Serial No.</u>	<u>Filing Date</u>	<u>Inventor(s)</u>
10/776,427	February 11, 2004	George M. Whitesides, et al.

PART III: Explanation of Non-English Language References and Remarks Concerning Other Information Cited

The following is a concise explanation of the relevance of each non-English language reference listed on the attached form PTO-1449 (modified):

Japanese reference JP 2140702 generally teaches a rotary variable focal mirror.

Japanese reference JP 2165933 generally teaches manufacture of mircolens arrays.

Japanese reference JP 2210302 generally teaches a focal distance variable mirror.

Japanese reference JP 58150148 generally teaches production of a stamper.

Applicants have provided translations of the abstracts of the foreign language references from the Japanese Patent Office. These translations are not the Applicants' translations.

Applicants do not concede to the accuracy of these translations, but are not aware of any inaccuracies.

The following are remarks concerning the other information cited:

PART IV: Remarks

Documents cited anywhere in the Information Disclosure Statement are enclosed unless otherwise indicated. It is respectfully requested that:

1. The Examiner consider completely the cited information, along with any other information, in reaching a determination concerning the patentability of the present claims;
2. The enclosed form PTO-1449 be signed by the Examiner to evidence that the cited information has been fully considered by the Patent and Trademark Office during the examination of this application;
3. The citations for the information be printed on any patent which issues from this application.

By submitting this Information Disclosure Statement, the Applicants make no representation that a search has been performed, of the extent of any search performed, or that more relevant information does not exist.

By submitting this Information Disclosure Statement, the Applicants make no representation that the information cited in the Statement is, or is considered to be, material to patentability as defined in 37 C.F.R. §1.56(b).

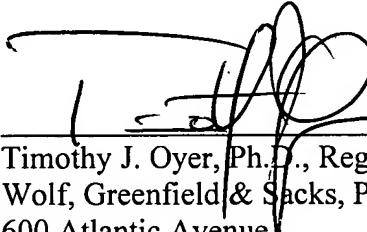
By submitting this Information Disclosure Statement, the Applicants make no representation that the information cited in the Statement is, or is considered to be, in fact, prior art as defined by 35 U.S.C. §102.

Notwithstanding any statements by the Applicants, the Examiner is urged to form his or her own conclusion regarding the relevance of the cited information.

An early and favorable action is hereby requested.

Respectfully submitted,

By:

  
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Docket No.: H0498.70173US00  
Date: September 1, 2005  
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FORM PTO-1449/A and B (Modified) SEP 06 2005 <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <small>U.S. PATENT AND TRADEMARK OFFICE</small>				APPLICATION NO.: 10/032,280	ATTY. DOCKET NO.: H0498.70173US00
				FILING DATE: 12/21/2001	CONFIRMATION NO.: 6387
Sheet 1 of 7				APPLICANT: Rahul Singhvi, et al.	
				GROUP ART UNIT: 1651	EXAMINER: Deborah K. Ware

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Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
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	B3	JP	2165933		Motoyuki	06-26-1990	Y, abstract only
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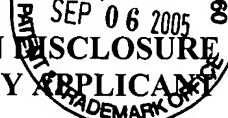
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B9	WO	01/03208	A1		President & Fellows of Harvard College	01-11-2001	
B10	WO	01/89787	A2		President & Fellows of Harvard College	11-29-2001	
B11	WO	01/89788	A2		President and Fellows of Harvard College	11-29-2001	

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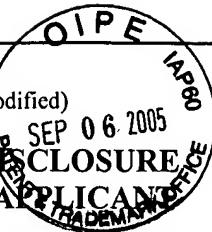
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Sheet 6 of 7

APPLICATION NO.:	10/032,280	ATTY. DOCKET NO.:	H0498.70173US00
FILING DATE:	12/21/2001	CONFIRMATION NO.:	6387
APPLICANT: Rahul Singhvi, et al.			
GROUP ART UNIT:	1651	EXAMINER:	Deborah K. Ware

**OTHER ART — NON PATENT LITERATURE DOCUMENTS**

Examiner's Initials	Cite No	Include name of the author (in CAPITAL LETTERS) title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, relevant page(s), volume-issue number(s), publisher, city and/or country where published.	Translation (Y/N)
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EXAMINER:

DATE CONSIDERED:

#EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

a copy of this reference is not provided as it was previously cited by or submitted to the office in prior application Serial No. 09/373,334, filed August 12, 1999, and relied upon for an earlier filing date under 35 U.S.C. 120 (continuation, continuation-in-part, and divisional applications).

[NOTE - The Office hereby waives the requirement under 37 CFR 1.98 (a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. patent application publication for all U.S. national patent applications filed after June 30, 2003 and for all international applications that have entered the national stage under 35 USC 371 after June 30, 2003. See 37 CFR 1.491(b). For all patent applications filed on or before June 30, 2003, copies of cited U.S. patents and patent application publications are still required unless an eIDS is filed. Copies of all other patent(s), publication(s), or other information listed must still be provided, even if it was previously submitted to, or cited by, the U.S. Patent Office in an earlier application, unless the earlier application is identified by the IDS and is relied upon for an earlier filing date under 35 U.S.C. §120, and the copy was provided in the earlier application.]